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Attorney Docket No. INK-002

PATENT APPLICATION

DEC 22 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): In Kwon Jeong

Group Art Unit: 3723

Serial No. 10/829,593

Confirmation No. 6718

Filed: April 21, 2004

Examiner: Rachuba, Maurina T.

For: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR
WAFERS USING ONE OR MORE POLISHING SURFACESMail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450RESPONSE TO OFFICE ACTION

Sir/Madam:

In response to the Office Action mailed on September 29, 2005, please consider the following **Remarks**, which begin on page 2 of this paper.

CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on December 22, 2005.

Number of Pages: 6 (including TRANSMITTAL LETTER)

Signed: Thomas H. Ham

Typed Name: Thomas H. Ham